# PATENT APPLICATION

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78871

Takashi CHUMAN, et al.

Appln. No.: 10/750,975

Group Art Unit: 1756

Confirmation No.: 1860

Examiner: Stephen D. ROSASCO

Filed: January 5, 2004

For:

MASK USED FOR LAYER AND PROCESS OF MAKING THE MASK

# AMENDMENT UNDER 37 C.F.R. § 1.111

# MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 3, 2006, please amend the above-identified application as follows on the accompanying pages.

# TABLE OF CONTENTS

AMENDMENTS TO THE SPECIFICATION	. 4
AMENDMENTS TO THE CLAIMS	. :
REMARKS	